

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional)  
**YPL-0073**

Application Number  
**10/765,366**

Applicant(s)  
**Sun-hee Kim, et al.**

Filing Date  
**1-27-2004**

Group Art Unit  
**NYA**

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AB		6,156,389	12-5-2000	Brown, et al.	427	393.4	12-28-1998
AB		6,261,431 B1	7-17-2001	Mathies, et al.	204	601	12-28-1998
AB		6,475,722 B1	11-5-2002	Henck	435	6	11-16-1998

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

AB		"Chip PCR. I. Surface passivation of microfabricated silicon-glass chips for PCR"; Authors: Mann A. Shoffner, Jing Cheng, Georgi E. Hvichia, Larry J. Kricka and Peter Wilding; Nucleic Acids Research, Vol. 24, No. 2; Oxford University Press; 1996; Pgs. 375-379
AB		"Miniaturized flow-through PCR with different template types in a silicon chip thermocycler"; Authors: Ivonne SchneegaB, Reiner Brautigamb and Johann Michael Kohler; LAB ON A CHIP, Vol. 1; The Royal Society of Chemistry; 2001; Pgs. 42-49

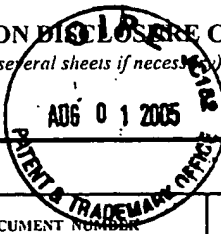
EXAMINER /Angela Bertagna/

DATE CONSIDERED 09/26/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*EXAMINER INITIAL	OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>		
AB	"Microfluidic tectonics: A comprehensive construction platform for microfluidic systems"; Authors: David J. Beebe, Jeffrey S. Moore, Qing Yu, Robin H. Liu, Mary L. Kraft, Byung-Ho Jo and Chelladurai Devadoss; PNAS, Vol. 97, No. 25; December 5, 2000; Pgs. 13488-13493		
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**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AB		6,277,480 B1	8-21-2001	Veerasamy, et al.	428	217	9-7-2000

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AB		2002/0050456 A1	5-2-2002	Sheppard, JR., et . al	204	451	5-15-2001

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**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

AB		"Fluoroalkylsilane Monolayers Formed by Chemical Vapor Surface Modification on Hydroxylated Oxide Surfaces"; Authors: Atsushi Hozumi, Kazuya Ushiyama, Hiroyuki Sugimura and Osamu Takai; XP8003176; American Chemical Society; Langmuir, Vol. 15, No. 22, 1999; Pgs. 7600 - 7604
AB		European Search Report; Application No. 04001605.5-1215-; Date of Completion: June 1, 2005

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